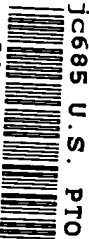


03/23/00



JC685 U.S. PTO



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**BOX: PATENT APPLICATION**

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Re: Application of Masami HATORI  
**SEMICONDUCTOR LASER MODULE AND METHOD FOR FORMING SEMICONDUCTOR LASER  
MODULE**  
Our Reference: Q56799

Dear Sir:

Attached hereto is the application identified above including the specification, claims and twelve (12) sheets of drawings. The requisite U.S. Government Filing Fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.

The Government filing fee is calculated as follows:

Total Claims	15 - 20 =	0 x \$18 =	\$ 000.00
Independent Claims	2 - 3 =	0 x \$78 =	\$ 000.00
Base Filing Fee	(\$690.00)		\$ 690.00
Multiple Dep. Claim Fee	(\$260.00)		\$ 000.00
<b>TOTAL FILING FEE</b>			<b>\$ 690.00</b>

Priority is claimed from:

Japanese Patent Application

11-93845

Filing Date

March 31, 1999

The priority document will be submitted at a later date.

Respectfully submitted,  
SUGHRUE, MION, ZINN, MACPEAK & SEAS  
Attorneys for Applicant(s)

By:

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